



Serial No. 10/757,410  
SEC.861D  
Amendment dated February 13, 2006

*IN THE UNITED STATES PATENT AND TRADEMARK OFFICE*

In re Patent application of :  
Jae-dong Lee et al. : Group Art Unit 1765  
Serial No. 10/757,410 : Examiner Lynette T. Umez-Eronini  
Filed January 15, 2004 :

CHEMICAL MECHANICAL POLISHING SLURRY

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**AMENDMENT**

U.S. Patent and Trademark Office  
Customer Service Window, **Mail Stop Amendment**  
Randolph Building  
401 Dulany Street  
Alexandria VA 22314

Sir:

In response to the Office Action dated September 21, 2005, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.